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PATENT  
Attorney Docket No.: 018865-003200US  
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Assistant Commissioner for Patents  
Washington, D.C. 20231

By: Sherry Barton

4/15/02  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Marchant et al.

Application No.: 09/405,210

Filed: September 24, 1999

For: METHOD OF MANUFACTURING  
TRENCH FIELD EFFECT  
TRANSISTORS WITH TRENCHED  
HEAVY BODY

Examiner: Vu, David

Art Unit: 2818

AMENDMENT

RECEIVED  
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TECHNOLOGY CENTER 2800

Assistant Commissioner for Patents  
Washington, D.C. 20231

In response to the Office Action mailed December 20, 2001, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claim 1 as follows:

1. (Once Amended) A method of manufacturing a trench field effect transistor on a substrate having a first conductivity type, the method comprising the steps of:

forming a first trench extending into the substrate;

B' sub C1